

ECSCRM2000 SPONSORS:

Deutsche Forschungsgemeinschaft
European Commission, High-Level Scientific Conferences Contract No.
HPCF-CT-1999-00181
US-ARL-European Research Office
US-Office of Naval Research International Field Office

CORPORATE SPONSORS:

Cree
Aixtron
DaimlerChrysler
Emcore
Epigress
H. C. Starck
Infineon Technologies
Leybold
NovaSiC
Omicron
Phys Tech
Saes Getters
SiCrystal
Siemens
Specs
Steag RTP Systems
Sterling Semiconductors
TDI
Triple-O Microscopy
II-VI Incorporated
Varian
Wacker Siltronic

ECSCRM2000 CHAIRPERSONS:

G. Pensl University of Erlangen-Nürnberg, Germany
D. Stephani SiCED, Erlangen, Germany

ECSCRM2000 LOCAL COMMITTEE:

M. Bockstedte University of Erlangen-Nürnberg
R. Eckstein SiCrystal AG
T. Frank University of Erlangen-Nürnberg
D. Hofmann University of Erlangen-Nürnberg
M. Hundhausen University of Erlangen-Nürnberg
O. Klettke University of Erlangen-Nürnberg
M. Krieger University of Erlangen-Nürnberg
M. Laube University of Erlangen-Nürnberg
G. Loy University of Erlangen-Nürnberg
N. Schulze University of Erlangen-Nürnberg
A. Seubert University of Erlangen-Nürnberg
U. Starke University of Erlangen-Nürnberg
M. Weidner University of Erlangen-Nürnberg

ECSCRM2000 STEERING COMMITTEE:

C. Brylinski	Thomson CSF/LCR, France
W. J. Choyke	University of Pittsburgh, USA
V. Dmitriev	TDI/Ioffe Institute, St.Petersburg, Russia
C. Harris	ACREO, Sweden
R. Helbig	University of Erlangen-Nürnberg, Germany
E. Janzen	University of Linköping, Sweden
H. Matsunami	Kyoto University, Japan
B. Monemar	University of Linköping, Sweden
J. Robert	University of Montpellier II, France
D. Siche	Institute of Crystal Growth, Berlin, Germany
J. Stoemenos	Aristotle University of Thessaloniki, Greece
A. Winnacker	University of Erlangen-Nürnberg, Germany

ECSCRM2000 PROGRAM COMMITTEE:

F. Bechstedt	University of Jena, Germany
J. Camassel	University of Montpellier II, France
E. Janzen	University of Linköping, Sweden
R. Madar	LMGP/UMR 5628 INPG/CNRS/ENSPG, France
H. Mitlehner	SiCED, Erlangen, Germany
B. Monemar	University of Linköping, Sweden
R. Nieminen	Helsinki University of Technology, Finland
J. Stoemenos	Aristotle University of Thessaloniki, Greece
M. Stutzmann	Walter-Schottky-Institute, TU München, Germany
B. Svensson	KTH, Stockholm, Sweden